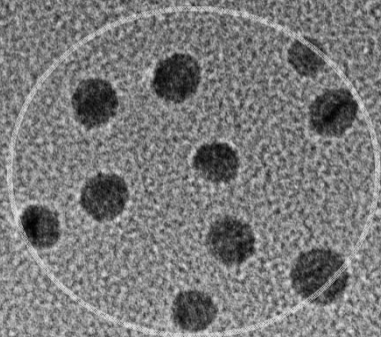
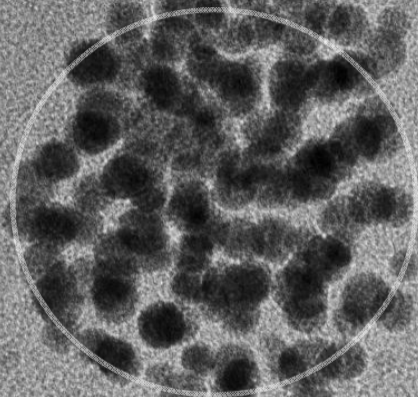


A 50 nm AbBNP with 10 Ab/BNP

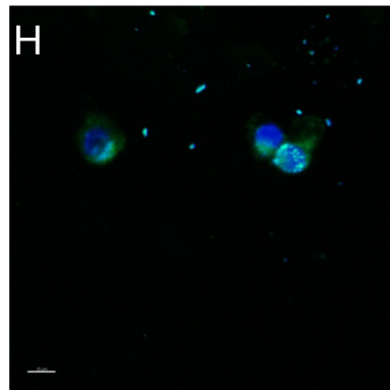
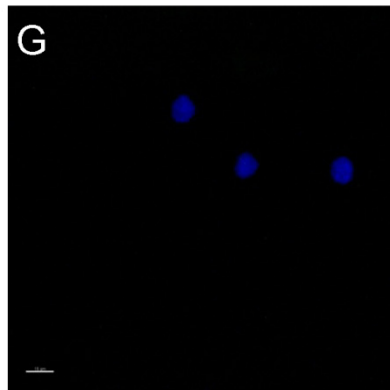
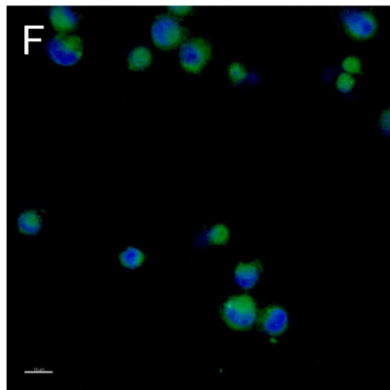
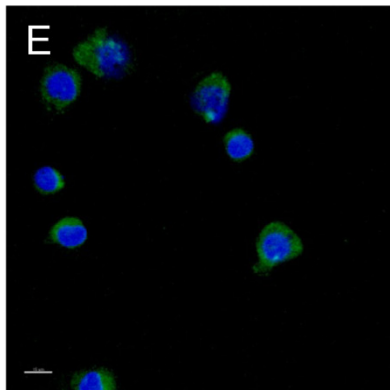
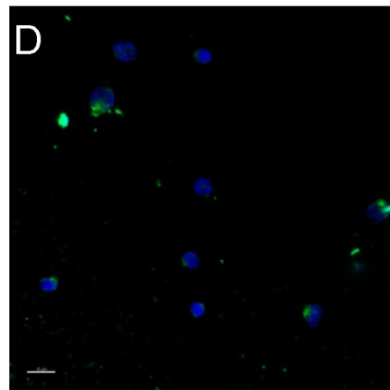
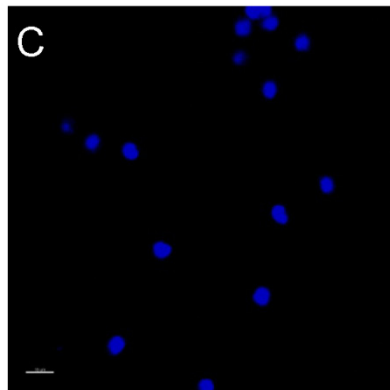
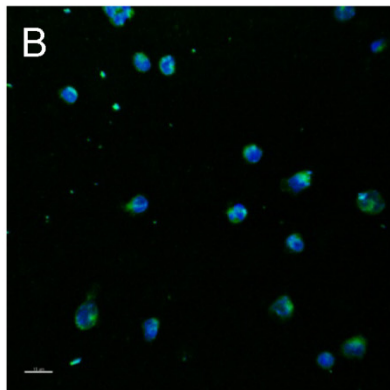
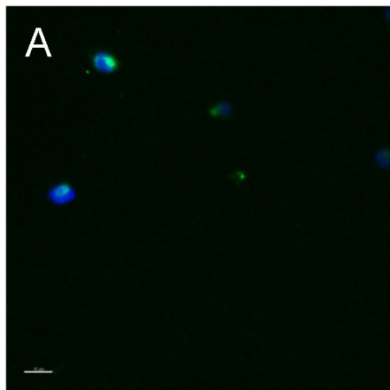


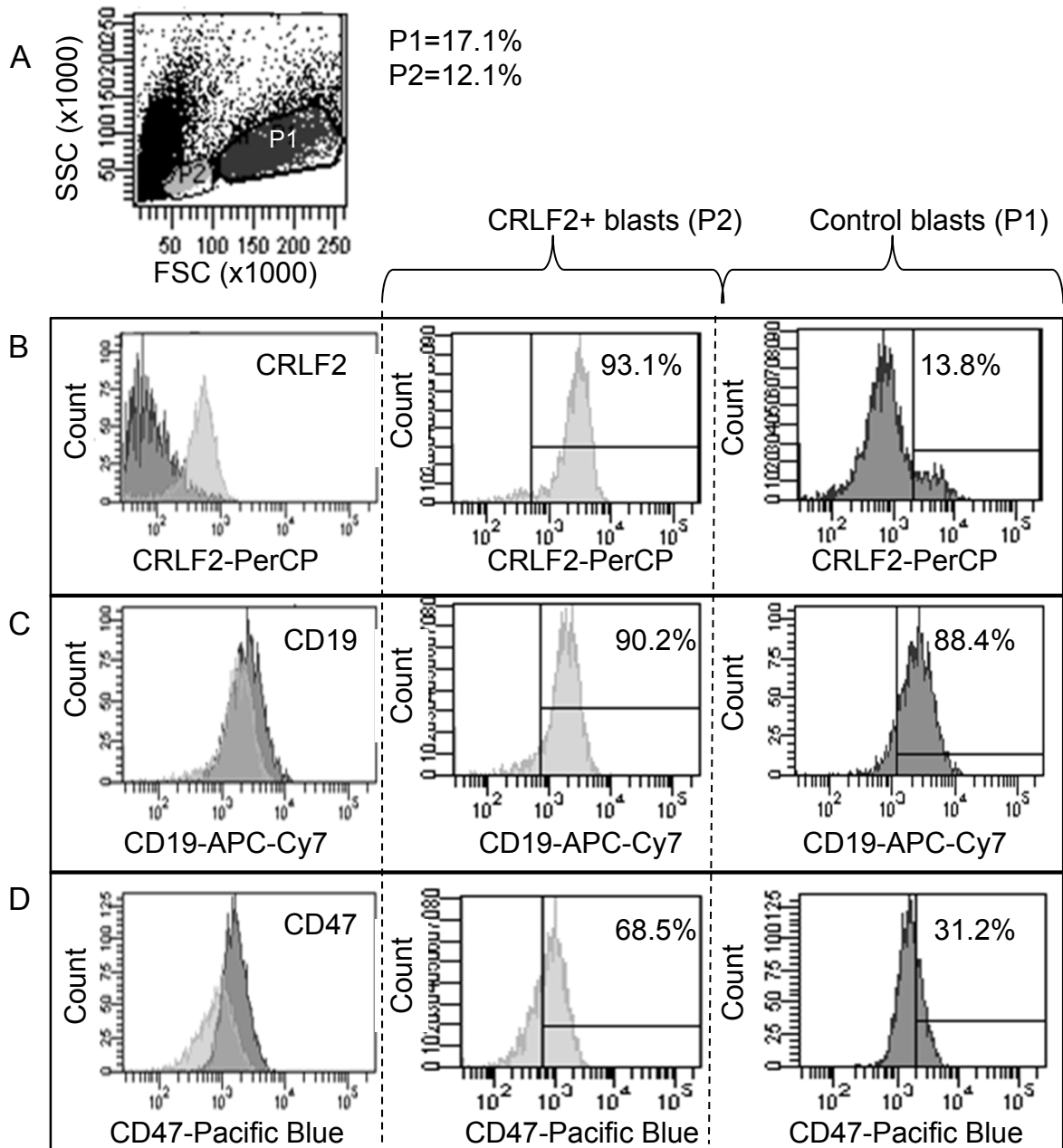
20 nm

B 50 nm AbBNP with 100 Ab/BNP



20 nm

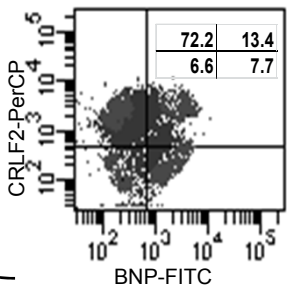
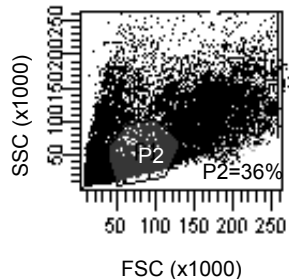
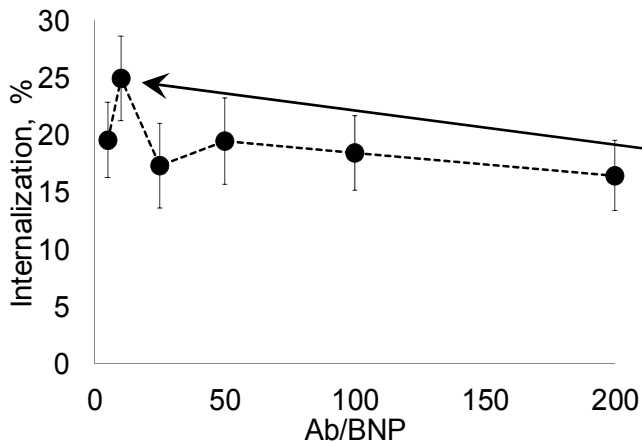




50 nm AbBNPs; CRLF2+ blasts

50 nm with 10 Ab/BNP

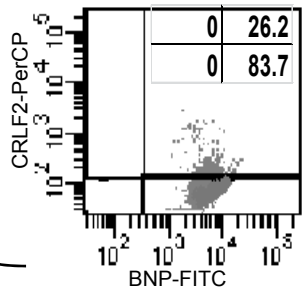
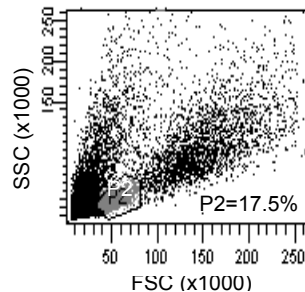
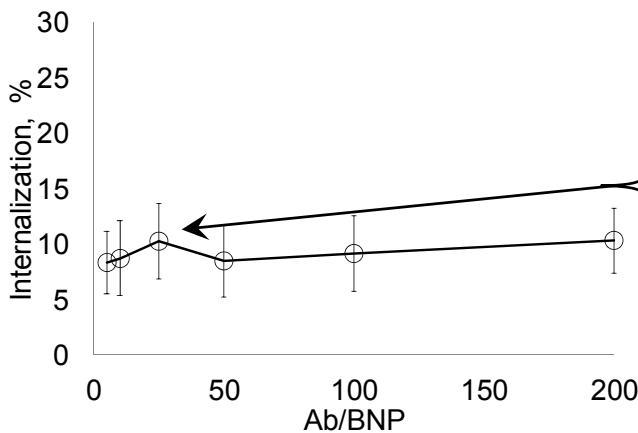
A

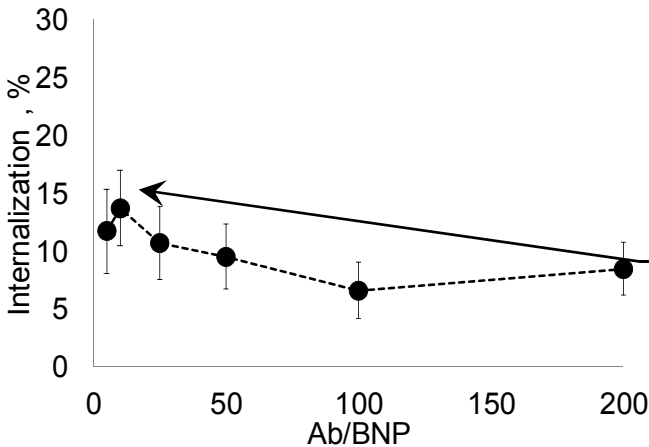


100 nm AbBNPs; CRLF2+ blasts

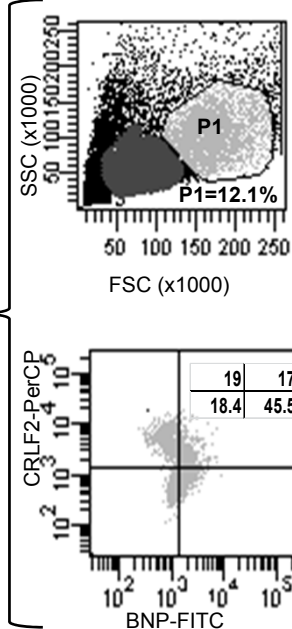
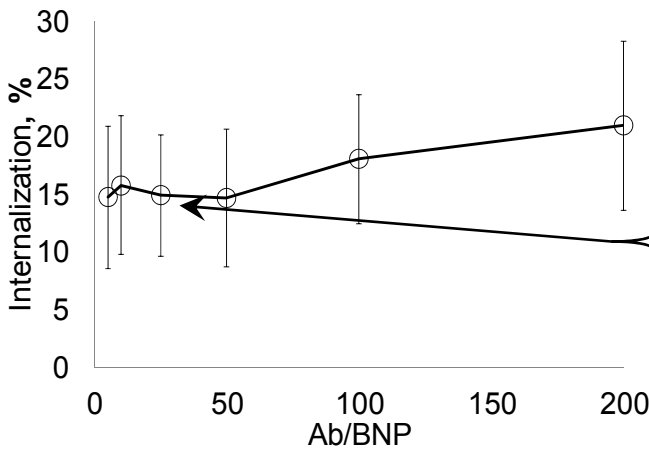
100 nm with 25 Ab/BNP

B

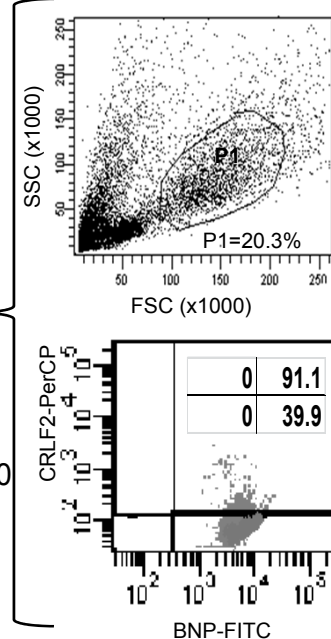


C 50 nm AbBNPs; control blasts

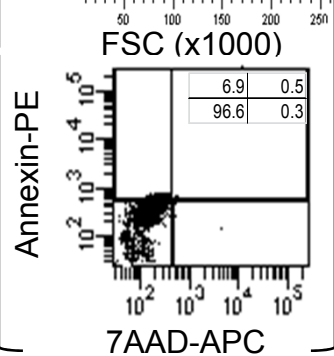
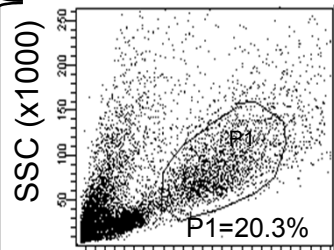
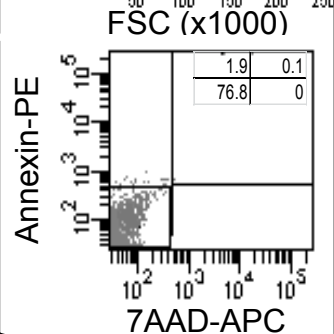
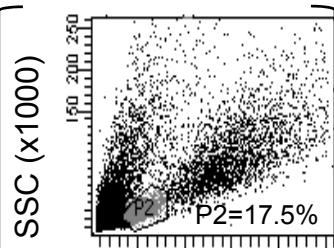
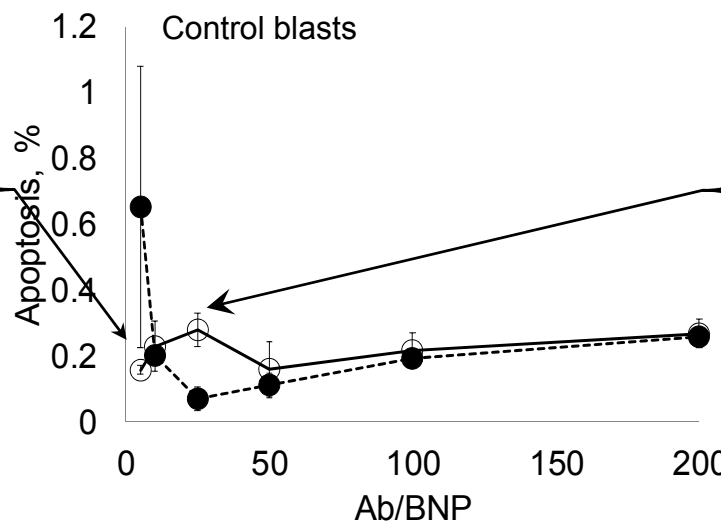
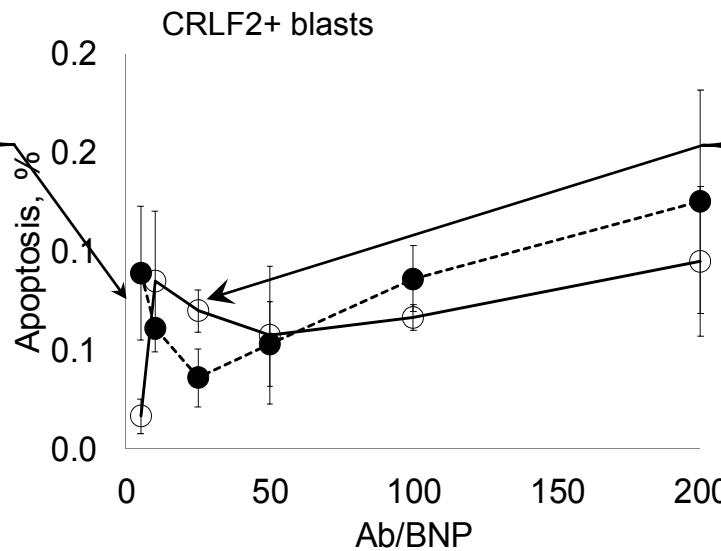
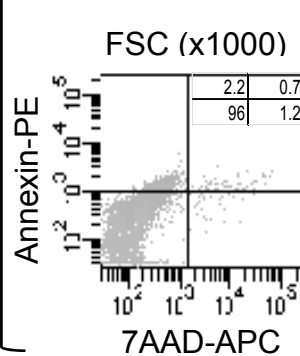
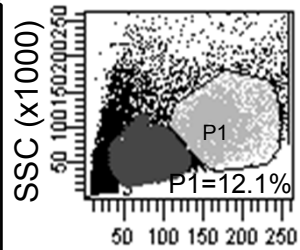
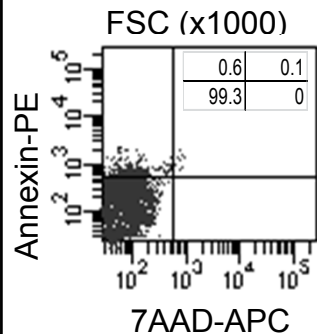
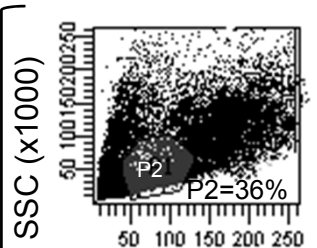
50 nm with 10 Ab/BNP

**D** 100 nm AbBNPs; control blasts

100 nm with 25 Ab/BNP



50 nm with 10Ab/BNP



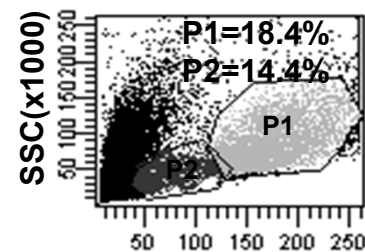
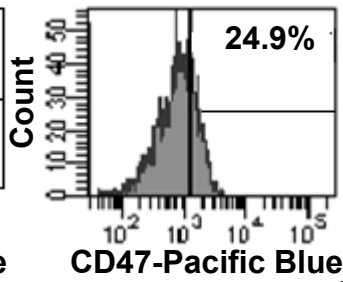
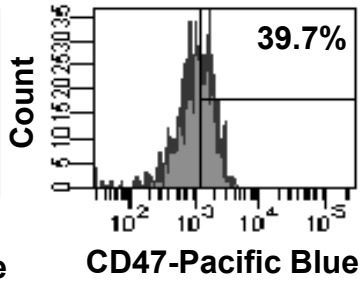
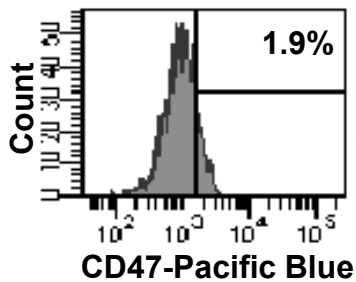
100 nm with 25Ab/BNP

No AbBNPs

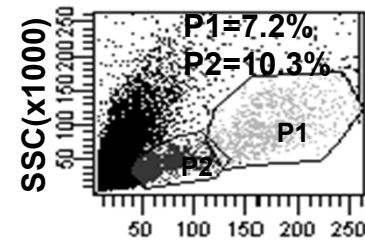
50 nm with 10Ab/BNP

100 nm with 25 Ab/BNP

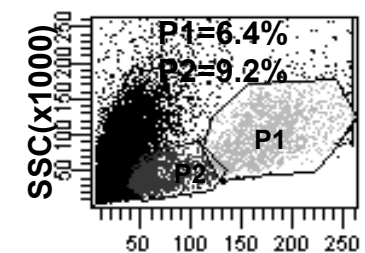
CRLF2+ blasts (P2)



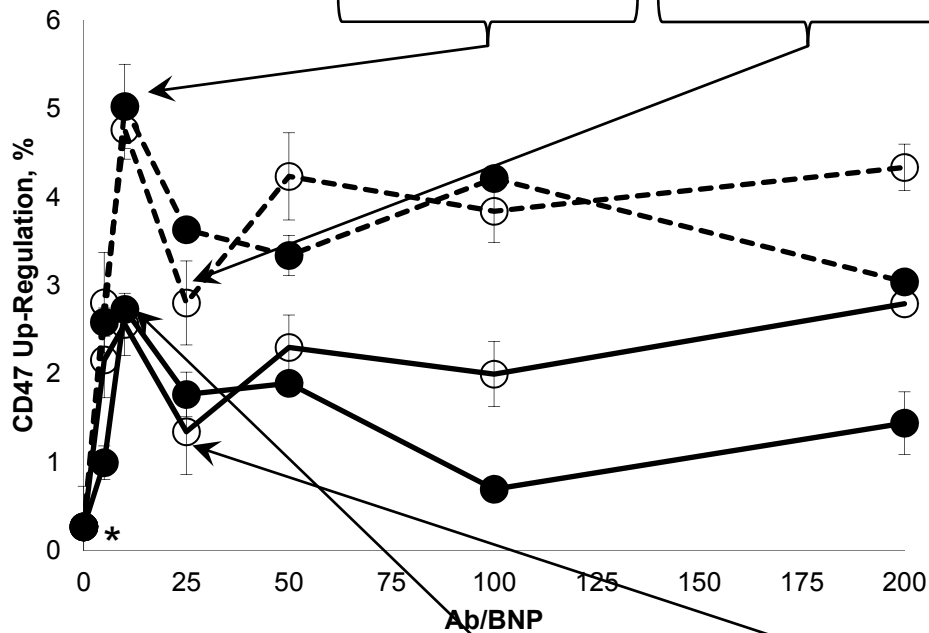
No AbBNPs



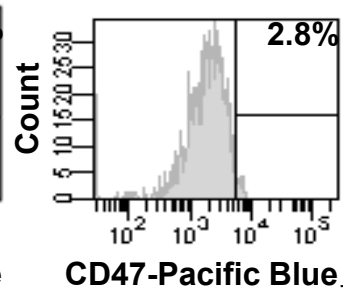
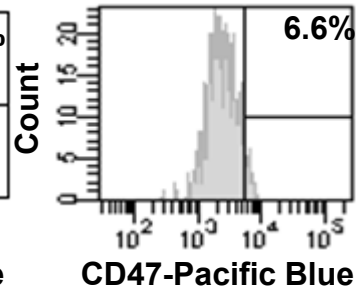
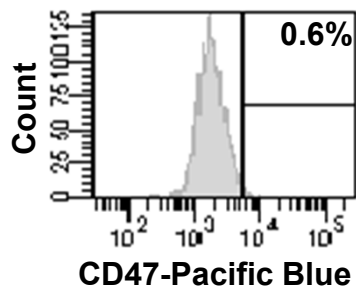
50 nm with 10Ab/BNP



100 nm with 25 Ab/BNP



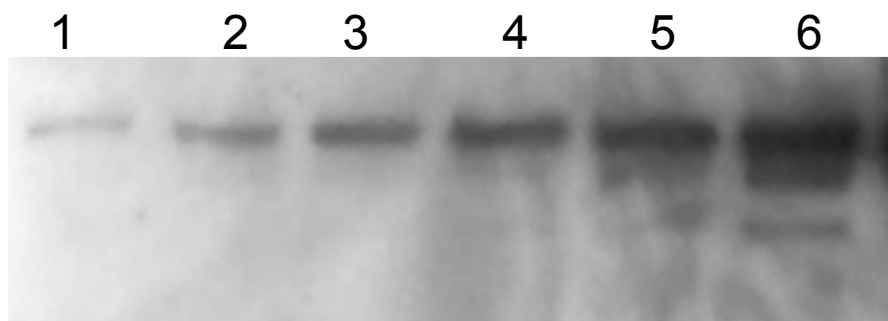
Control blasts (P1)



No AbBNPs

50 nm with 10Ab/BNP

100 nm with 25 Ab/BNP

A**B**